

QCO.091A



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wen-Jian Lin  
Appl. No. : 10/810,660  
Filed : March 29, 2004  
For : STRUCTURE OF A MICRO  
ELECTRO MECHANICAL  
SYSTEM AND THE  
MANUFACTURING METHOD  
THEREOF  
Examiner : Jarrett J. Stark  
Group Art Unit : 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 6, 2006

(Date)

*Ryan E. Melnick*

Ryan E. Melnick, Reg. No. 58,621

AMENDMENT

**Mail Stop RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed June 6, 2006, please find the enclosed amendments and remarks. This response is a submission under 37 CFR § 1.114(a) and is being accompanied by a Request for Continued Examination.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Summary of Interview** begins on page 9 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.